

APR-26-2002 15:40 FROM

TO 76#1309022\*1299#1703 P.03/13

11/Sup:  
FDS  
6/3/02  
J.W.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/428,125  
Filing Date ..... October 26, 1999  
Inventor ..... Vishnu K. Agarwal et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2822  
Examiner ..... K. Rose  
Attorney's Docket No. .... MI22-1299  
Title: Capacitors and Methods of Forming Capacitors

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

References -See Attached Form PTO-1449

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449, copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.

Respectfully submitted,

Dated: 4-26-2002

By:

Jennifer J. Taylor  
Reg. No. 48,711

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